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**1 Electrical and reliability characteristics of an ultrathin TaO/sub x/N/sub y gate dielectric prepared by ND/sub 3/ annealing of Ta/sub 2/O/sub 5/**  
*Hyungsuk Jung; Kiju Im; Dooyoung Yang; Hyunsang Hwang*  
 IEEE Electron Device Letters, Volume: 21 Issue: 12, Dec. 2000  
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**2 Anodization for forming thin film embedded capacitors in MCM-D and MCM substrates**

*Nelms, D.; Ulrich, R.; Schaper, L.; Reeder, S.*

Electronic Components & Technology Conference, 1998. 48th IEEE, 1998

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[\[Abstract\]](#) [\[PDF Full-Text \(476 KB\)\]](#) **CNF**

**3 Formation and magneto-structural properties of the new Nd/sub 3/Fe/sub 29-x/W/sub x/ intermetallic phase**

*Sanchez, J.L.; Neiva, A.C.; Marques, J.M.; Missell, F.P.; de Amorin, H.S.; Domingues P.H.; Amaral, M.R., Jr.*

Magnetics, IEEE Transactions on, Volume: 33 Issue: 5 Part: 2, Sept. 1997

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